



Docket No. 740756-2101

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Patent Application of:

Shunpei YAMAZAKI et al.

Application No. 09/502,675

Filed: February 11, 2000

For: SEMICONDUCTOR DEVICE AND METHOD
OF MANUFACTURING THEREFOR

)

) Group Art Unit: 2829

) Examiner: Evan T. Pert

) Confirmation No. 5514

) Date: February 5, 2004

CERTIFICATE OF MAILING OR TRANSMISSION
[37 CFR 1.8(a)]

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage for First Class Mail in an envelope addressed to: Mail Stop **RCE**, Commissioner for Patents, P.O. Box 1450, Alexandria, Virginia 22313-1450, on February 5, 2004.

Signature: Deborah Movahhedi
Name: Deborah Movahhedi

PRELIMINARY AMENDMENT

Mail Stop **RCE**
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Quayle Action mailed November 5, 2003, Applicants are submitting herewith a Request for Continued Examination (RCE), Preliminary Amendment, and Information Disclosure Statement in connection with the above-identified application.